

Notice of References Cited		Application/Control No. 10/582,635	Applicant(s)/Patent Under Reexamination CHOI ET AL.	
		Examiner Angelica Ruiz	Art Unit 2169	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,848,137 A	12-1998	Hsiao, Ray-Ling	379/110.01
*	B	US-2002/0152244 A1	10-2002	Dean et al.	707/530
*	C	US-2002/0167545 A1	11-2002	Kang et al.	345/780
*	D	US-2002/0198006 A1	12-2002	Hirayama et al.	455/456
*	E	US-2003/0024765 A1	02-2003	Sugiura et al.	181/199
*	F	US-2003/0040346 A1	02-2003	Fukuda et al.	455/575
*	G	US-2003/0043215 A1	03-2003	Nomura et al.	345/864
*	H	US-2003/0056222 A1	03-2003	Iwata et al.	725/87
*	I	US-2003/0177503 A1	09-2003	Sull et al.	725/112
*	J	US-2003/0079234	04-2003	Rasmussen, Lars Blak	725/153
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.